

Kazuyuki Iizuka

List of Publications by Year in descending order

Source: <https://exaly.com/author-pdf/11017486/publications.pdf>

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3
papers

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citations

2258059

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2550090

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76
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#	ARTICLE	IF	CITATIONS
1	Highly sensitive formaldehyde sensors based on catalyst added porous films fabricated by plasma spray physical vapor deposition. <i>Sensors and Actuators B: Chemical</i> , 2013, 182, 250-255.	7.8	8
2	Highly sensitive SnO ₂ porous film gas sensors fabricated by plasma spray physical vapor deposition. <i>Sensors and Actuators B: Chemical</i> , 2012, 173, 455-461.	7.8	31
3	Growth of tin oxide thick films by plasma spray physical vapor deposition. <i>Sensors and Actuators B: Chemical</i> , 2011, 155, 551-556.	7.8	12